



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Mohammad B. SHABANI et al.

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**METHOD FOR ANALYZING IMPURITIES
IN A SILICON SUBSTRATE AND
APPARATUS FOR DECOMPOSING
SILICON SUBSTRATE THROUGH
VAPOR-PHASE REACTION**

Commissioner for Patents
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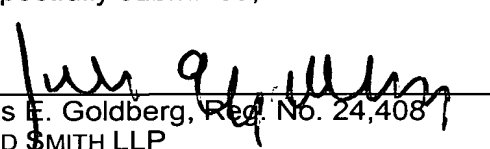
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Respectfully submitted,

Dated: December 16, 2005


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